



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
)  
Shunpei Yamazaki et al. )  
)  
Serial No.: 09/544,801 )  
)  
Filed: April 7, 2000 )  
)  
For: Semiconductor Device And Method )  
For Fabricating The Same )  
)  
Art Unit: 2826 )  
)  
Examiner: Fazli Erdem )

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to:  
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Shannon Wallace  
Name of applicant, assignee, or Registered Rep.  
Shannon Wallace 6/26/06  
Signature Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT G (AFTER FINAL)**

Sir:

In response to the Final Rejection dated April 24, 2006, a RCE being filed herewith,  
please amend the above-identified application as follows: